

IFW

PATENT



MICRON.251DV1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Nejad et al.  
App. No. : 10/637,096  
Filed : August 8, 2003  
For : PROCESS FLOW FOR  
BUILDING MRAM  
STRUCTURES  
Examiner : Unknown

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

February 4, 2005

(Date)

Linda H. Liu, Reg. No. 51,240

STATUS LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Our file for the subject application reveals that there has been no action in this application since February 12, 2004.

Please inform us as to the status of this application.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 2/1/2005

By: [Signature]

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